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	Application No.	Applicant(s)	
Notice of Allered life	10/718,691	NAKASHIMA ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Mai-Huong Tran	2818	
The MAILING DATE of this communication appeal of the communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate comming IGHTS. This application is:	n this application. If not include unication will be mailed in due c	d :ourse. THIS
1. This communication is responsive to 11/24/03.			
2. ☑ The allowed claim(s) is/are <u>4-6 and 10-12</u> .			
3. $igotimes$ The drawings filed on <u>24 November 2003</u> are accepted by	the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	e been received. e been received in Application	on No. <u>10/105,369</u> .	on from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the requ	uirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) ☐ including changes required by the Notice of Draftspers	son's Patent Drawing Revie	w (PTO-948) attached	
1) 🗌 hereto or 2) 📗 to Paper No./Mail Date	•		
(b) including changes required by the attached Examiner Paper No./Mail Date	s Amendment / Comment o	r in the Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			back) of
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT			ote the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Ir	nformal Patent Application (PTO	-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview S	summary (PTO-413),	·
 Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 11/24/03 Examiner's Comment Regarding Requirement for Deposit 	08), 7. Examiner's	/Mail Date Amendment/Comment Statement of Reasons for Allov	wance
of Biological Material	9.		varice
Su	David Nelms pervisory Patent Examiner		
	Technology Center 2800		

Reason for allowance

The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed a method for producing an electrode adapted for use with a silicon carbide semiconductor, and comprises a p-type silicon layer formed on p-type silicon carbide, and a metal silicide layer formed on the p-type silicon layer, which method comprises forming the metal silicide layer by means of laser ablation.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mai-Huong Tran whose telephone number is (571)-272-1796. The examiner can normally be reached on Monday-Thursday 8:00am-6:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers for

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the organization where this application or proceeding is assigned are (703) 872-9306 for regular communications and (703) 308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 872-9319.

Mai-Huong Tran

David Nelms
Supervisory Patent Examiner
Technology Center 2800

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